

SUPPLEMENTAL APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Number:: 10/572,353
Application Date:: 03/16/06
Application Type:: REGULAR
Subject Matter:: UTILITY
CD-ROM or CD-R?: NONE
Title:: MICROLITHOGRAPHY METHOD USING
A MASK WITH CURVED SURFACE
Attorney Docket Number:: 287990US2PCT
Total Drawing Sheets:: 4

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: France
Status:: FULL CAPACITY
Given Name:: Jean-Charles
Family Name:: GUIBERT
City of Residence:: SAINT ETIENNE DE CROSSEY
Country of Residence:: France
Street of Mailing Address:: 4 Beau Rivoire
City of Mailing Address:: SAINT ETIENNE DE CROSSEY
Country of Mailing Address:: France
Postal or Zip Code of Mailing Address:: F-38960

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/FR04/50433	09/15/04

FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
03 50561	France	09/17/03	YES

ASSIGNMENT INFORMATION

Assignee Name::	COMMISSARIAT A L'ENERGIE ATOMIQUE
Street of Mailing Address::	31-33 rue de la Federation
City of Mailing Address::	Paris 15 ème
Country of Mailing Address::	France
Postal or Zip Code of Mailing Address::	F-75752